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PATENT AP01983 7.7.

IN THE CONTENT STATES PATENT AND TRADEMARK OFFICE

In re application of:

Chen, Shiuh -Hui et al.

Attorney Docket No.:

AP01989

Serial No.:

10/058,557

Art Unit:

2812

Filing Date:

01/28/02

Examiner:

Unassigned

Confirmation No.:

4319

For:

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METHODS OF MAKING THE SAME

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO:

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WASHINGTON, D.C. 20231, ON:_

Date of Deposit

MOTOROLA INC.

Name of Assignee

Jaya Sehen

3/29/02

INFORMATION DISCLOSURE STATEMENT (IDS)

Assistant Commissioner For Patents Washington, D.C. 20231

SIR:

In accordance with 37 C.F.R. §1.56 and in compliance with 37 C.F.R. §§1.97 and 1.98, the references listed on attached Form PTO/SB/08 and/or subsequently identified herein, are being submitted herewith for consideration by the United States Patent and Trademark Office.

I. COPIES

a. A legible copy of (i) each U.S. and foreign patents; (ii) each publication or that portion which caused it to be listed; and (iii) all other information or that portion which caused it to be listed, is included herewith.

	b.	Any patents, publications or other information which are listed on PTO/SB/08 which are not enclosed herewith were previously cited by or submitted to the PTO in one of the followin applications which has been relied upon for an earlier filing date under 35 U.S.C. §120:					
		U.S. Serial Number	U.S. Filing Date				
II.	CONC	ISE EXPLANATION OF THE RELEVANCE (check	at least one box)				
	a. 🛛	Except as may be indicated below in (b) of this second other information are in the English language (concise					
	b. 🔲	A concise explanation of the relevance of all pate					
	_	listed that is not in the English language is as follows					
	c. [The following additional information is provided for	the Examiner's consideration:				
ш. 🗀	CROSS REFERENCE TO RELATED APPLICATION(S) The Examiner is advised that the following co-pending application(s) contain(s) subject matter that may be related to the present application. By bringing this (these) applications to the Examiner's attention, Applicant(s) does(do) not waive the confidentiality provisions of 35 U.S.C. §122.						
	<u>Serial</u>	No. Filing Date	Art Unit				
		<u>FEES</u>					
IV. 🔲	THIS	IDS IS BEING FILED UNDER 37 C.F.R. §1.97(b)	(check one box)				
	a. 🖂	within three months of the filing date of a nation	al application (37 C.F.R. §1.97(b)(1)).				
		No fee or statement is required.					
	b. within three months of the date of entry of the national stage as set forth in § 1.491 in international application (37 C.F.R. §1.97(b)(2)). No fee or statement is required.						
	c. 🗌	before the mailing date of a first Office Action	on the merits (37 C.F.R. §1.97(b)(3)).				
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	d.	In the event that a first Office Action on the meri					
		IDS under 37 C.F.R. §1.97(c) and see the statem					
		below, or if no statement has been made, charg	e deposit account 13-4771 the fee set				
		forth in 37 C.F.R. §1.17(p).					

V. 🔲	THIS I	DS IS BEING FILED UNDER 37 C.F.R. §1.97(c): (check one box)
	before	the mailing date of either a Final Office Action under 37 C.F.R. §1.113 (See 37 C.F.R.
	§1.97(c)), or a Notice of Allowance under 37 C.F.R. §1.311 (See 37 C.F.R. §1.97(c)).
	a. 🗌	No statement; therefore, charge deposit account 13-4771 the fee set forth in 37 C.F.R.
		§1.17(p).
	b. 🗌	See the statement below. No fee is required.
VI. 🗌	THIS I	DS IS BEING FILED UNDER 37 C.F.R. §1.97(d):
	on or b	before payment of the issue fee and is accompanied by the following:
	1)	a statement under 37 C.F.R. §1.97(e) as provided below;
	2)	Applicant(s) hereby a petition for consideration of this information disclosure statement; and
	3)	charge deposit account 13-4771 the petition fee set forth in §1.17(i).
VII.		ent under 37 C.F.R. §1.97(e) (check only one box, if applicable) dersigned hereby states that
	a.	each item of information contained in the IDS was cited in a communication from a
		foreign Patent Office is a counterpart foreign application not more than three months
		prior to the filing of IDS; or
	b	no item of information contained in the IDS was cited in a communication from a
		foreign Patent Office in a counterpart foreign application, and to knowledge of the
		person signing the statement after making reasonable inquiry, no item of information
		contained in the IDS was known to any individual designated in 37 C.F.R. 1.56(c) more
		than three months prior to the filing of this statement, or
	c.	some of the items of information contained in the IDS were cited in a communication
		from a foreign Patent Office. As to this information, the undersigned states that each
		item of information contained in the IDS was cited in a communication from a foreign
		Patent Office in a counterpart foreign application not more than three months prior to the
		filing of this IDS. As to the remaining information, the undersigned hereby states that
		no item of this remaining information contained in the IDS was cited in a
		communication from a foreign Patent Office in a counterpart foreign application or, to
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		item of information contained in the IDS was known to any individual designated in 37
		CFR 1.56(c) more than three months prior to the filing of this statement

VIII.	PAYN	ENT OF FEES
		A check in the amount of is enclosed for the above-identified fee(s). Please charge Deposit Account No.13-4772 in the amount of \$180.00 for the above-indicated fee(s).
		If Applicant has overlooked any additional fees, or if any overpayment has been made, the Commissioner is hereby authorized to credit or debit Deposit Account 13-4772
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candor anticip a perso unders to cons	and whates the on or or or or or igned.	pplicants' opinion that the claims presently on file patently distinguish the present each of these references. The above references are being cited only in the interests of thout any admission that they constitute statutory prior art or contain matter which invention or which would render the same obvious, either singly or in a combination, to inary skill in the art. Examiner has any questions concerning this IDS, he/she is requested to contact the fit is determined that this IDS has been filed under the wrong rule, the PTO is requested IDS under the proper rule (with a petition if necessary) and charge the appropriate fee to nt No. 13-4772.
		Respectfully submitted, Shiuh –Hui Chen et al.
		Thomas V. Miller INC. Attorney for Applicant(s) ber 22917 Reg. No. 42,002 Tel. (847) 538-7103 PTO/SB/08 References
		Foreign Search Report

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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

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Sheet	1		of

	Complete if Known
Application Number	10/058,557
Filing Date	01/28/02
First Named Inventor	Chen et al.
Group Art Unit	2812
Examiner Name	Unknown
Attorney Docket Number	AP01983

				U. S. PATENT DOCUMENT	rs	
Examiner Initials*	Cite No. ¹	U.S. Patent Number	Document Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		3,761,784		Jund	07/04/1989	
		4,191,057		Busta	05/27/1997	
		4,275,406		Muller et al.	06/23/81	
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		5,629,486		Viduya et al.	05/13/97	
		5,644,102		Rostoker	07/01/97	
		5,917,264		Maruno et al.	06/29/99	

				FOREIG	N PATENT DOCUME	NTS		
Examiner Initials*	Cite No. 1	Office ³	Foreign Patent Do Number ⁴	Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
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Examiner	Date	
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation, if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English Language Translation is attached.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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(use as many she	ets as necessary)	Examiner Name	Unknow		
Sheet	2	of	2	Attorney Docket Number	AP01983
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Complete if Known							
	Application Number	10/058,557	rii -				
	Filing Date	01/28/02	72				
	First Named Inventor	Chen et al.	る男に				
	Group Art Unit	2812	5 2 3				
	Examiner Name	Unknown	0 1				
	Attorney Docket Number	AP01983					

		OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or counter where published.	T ²
	:	"Micromachines on the March" Janusz Bryzek, Kurt Petersen, and Wendell McCulley. IEEE Spectur, May 1994, pp 20-31.	.`
		"Ultra Thin ICs Open New Dimensions for Microelectric Systems" G. Klink, C. Landesberger, M. Feil, F. Ansorge, R. Aschenbrenner. Advancing Microelectronics, July/August 2000; pp.23-25.	
		"New Process Scheme for Wafer Thinning and Stress-free Seperation of Ultra Thin ICs" C. Landesberger, S. Scherbaum, G. Schwinn, H. Spohrle. Proceedings of Microsystems Technologies 2001; ppx1-7.	
		"Innovative Packaging Concepts for Ultra Thin Integrated Circuits" G. Klink, M. Feil, F. Ansorge, R. Aschenbrenner, H. Reichl. Electonic Components and Technology Conference, 2001; pp. 1034-1039.	,
	`	"Thin Silicon Chips and ACF Connection Technology for Contactless IC Cards" Mitsuo Usami. 1999 International Symposium on Microelectronics; pp. 309-312.	,,
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,	•	"Thin Monocrystalline Silicon Films on Flexible Substrates Enable Multiple Transfer Processes" C. berge, Dr. R. Bergmann, D. J. Werner. MRS Bulletin, August 2001; pp. 603.	
		Khazan, A.D., "Transductors and Their Elements: Design and Application." Prentice-Hall, Inc. 1994, ISBN 03-13-929480-5. pp 393-395.	
	,	"Packaging Very High Pressure Transducers for Common Rail Diesel Injection Systems" K. Sidhu, Measurement Specialties, Inc. October 1987, pp. 1-4	. \

Examiner	Date	
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation, if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² Applicant is to place a check mark here if English Language Translation is attached.